

<b>Notice of References Cited</b>		Application/Control No. 10/539,326	Applicant(s)/Patent Under Reexamination VAN HOUTEN, HENDRIK	
		Examiner Aneeta Patankar	Art Unit 2627	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,493,312	12-2002	Negishi et al.	369/275.4
*	B	US-6,706,358	03-2004	McDaniel et al.	428/64.1
*	C	US-2003/0035361	02-2003	Knight et al.	369/112.24
*	D	US-2002/0098446	07-2002	Alperovich et al.	430/270.15
*	E	US-5,696,714	12-1997	Russell, James T.	365/106
*	F	US-5,472,759	12-1995	Chen et al.	428/65.1
*	G	US-6,144,631	11-2000	Kawano, Toshifumi	369/275.1
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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